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Name of Person Signing Wayne J. Egan

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Xerox Attorney Docket No.: D/A1104 Microscan Systems Incorporated Docket No. 52449-3

The undersigned are Xerox Corporation named inventors (the "Inventors") on a United States patent entitled **PROCESS FOR** MANUFACTURING MICROMECHANICAL MICROOPTOMECHANICAL STRUCTURES WITH SINGLE CRYSTAL SILICON EXPOSURE STEP (the "Application") for inventions disclosed or claimed therein (the "Invention(s)"), which Application: is being executed concurrently herewith, was first executed on ☐ claims the benefit of U.S. Provisional Application(s) No(s). 1 filed Xerox Corporation, a New York Corporation, on behalf of itself, its successors and assigns, and its legal representatives ("Xerox"), is entitled to all the below Inventors' rights in the Application and the Invention(s), and the full cooperation of the below Inventors. For valuable consideration, the receipt of which is hereby acknowledged, the below Inventors hereby sell, assign, and transfer to Xerox their entire and exclusive right, title and interest in the Application and the Invention(s), in and for the United States, its territories, and all foreign countries, including all applications, patents, design registrations and publications obtained or derived therefrom, world wide, and all priority rights under all present or future conventions and treaties, and any provisional applications for which priority is claimed in the Application; and request the U.S. Commissioner of Patents to issue all U.S. Letters Patent granted thereon to Xerox and Microscan Systems, Incorporated, as joint owners; agree that Xerox and Microscan Systems, Incorporated, as joint owners, may apply for and receive all foreign Letters Patent thereon; and

(3) agree to execute all papers and take all actions necessary or desirable in connection therewith as requested by Xerox or Microscan Systems, Incorporated.

Peter M. Gulvin

Date 3(2)/01

Jingkuang Chen

Date \_\_\_\_\_

Joel A. Kubby

Date \_\_\_\_\_

Chuang-Chia Lin

Date \_\_\_\_\_

Alex T. Tran

Date \_\_\_\_\_

PATENT REEL: 011699 FRAME: 0884

Xerox Attorney Docket No.: D/A1104 Microscan Systems Incorporated Docket No. 52449-3

The undersigned are Xerox Corporation named inventors (the "Inventors") on a United States patent application entitled PROCESS FOR MANUFACTURING MICROMECHANICAL AND MICROOPTOMECHANICAL STRUCTURES WITH SINGLE CRYSTAL SILICON EXPOSURE STEP (the "Application") for inventions disclosed or claimed therein (the "Invention(s)"), which Application:

is being executed concurrently herewith,			
was first executed on			
was filed on 11/27/2000 as Application Number 09/724,514.			
claims the benefit of U.S. Provisional Application(s) No(s).	1	filed	

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- (1) request the U.S. Commissioner of Patents to issue all U.S. Letters Patent granted thereon to Xerox and Microscan Systems, Incorporated, as joint owners;
- (2) agree that Xerox and Microscan Systems, Incorporated, as joint owners, may apply for and receive all foreign Letters Patent thereon; and
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Peter M. Gulvin	CD.	Date
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		,
Joel A. Kubby		
		Date
Chuang-Chia Lin		Data
		Date
Alex T. Tran	·	
		Date

PATENT REEL: 011699 FRAME: 0885

Xerox Attorney Docket No.: D/A1104 Microscan Systems Incorporated Docket No. 52449-3

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Peter M. Gulvin	Date
Jingkuang Chen	Date
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)	Date 3/12/0
Chuang-Chia Lin	Date
	<u></u>
Alex T. Tran	Data

PATENT REEL: 011699 FRAME: 0886

Xerox Attorney Docket No.: D/A1104 Microscan Systems Incorporated Docket No. 52449-3

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Date Month 16,2001

Chuang-Chia Lin

Alex T. Tran

PATENT

REEL: 011699 FRAME: 0887

Xerox Attorney Docket No.: D/A1104 Microscan Systems Incorporated Docket No. 52449-3

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Date \_\_\_\_\_

3/15/2001

Chuang-Chia Lin

RECORDED: 04/05/2001

PATENT

REEL: 011699 FRAME: 0888